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AUG 30 2004

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
PATENT APPLICATION

Application No.: 09/683,088  
Applicant: Chu et al.  
Filing Date: November 16, 2001  
Title: **SINGLE REACTOR, MULTI-  
PRESSURE CHEMICAL VAPOR  
DEPOSITION FOR SEMICONDUCTOR  
DEVICES**

Atty. Docket: BUR9-2000-0077-US1  
Today's Date: August 30, 2004  
Examiner: Matthew J. Song  
Group Art Unit: 1765  
Fax: 703-872-9306

## Amendments Under 37 CFR 1.114

## Amendment C

Honorable Commissioner for Patents and Trademarks  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 28, 2004, Applicants respectfully request reconsideration of the outstanding rejections and reexamination of the present application in light of the following amendments and remarks for which a timely response is being filed on Monday, August 30, 2004 within the three month period for reply.

CERTIFICATE OF MAILING	
I hereby certify that, on the date shown below, this correspondence is being:	
<b>MAIL</b>	<b>FACSIMILE</b>
<input type="checkbox"/> deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450.	<input checked="" type="checkbox"/> transmitted by facsimile to the Patent and Trademark Office.
Date: <u>AUG. 30, 2004</u>	<u>ANTHONY J. CANAZE</u> Name <u>Anthony J. Canale</u> Signature

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